

L Number	Hits	Search Text	DB	Time stamp
2	1	((semiconductor) and (conductive or conductor or interconnect or interconnection or interconnecting) and dielectric and (ablate or erosion or ablation or erode or eroded or ablated) and (deposit or deposition or deposited)) and laser	USOCR	2004/05/11 09:38
1	17	(semiconductor) and (conductive or conductor or interconnect or interconnection or interconnecting) and dielectric and (ablate or erosion or ablation or erode or eroded or ablated) and (deposit or deposition or deposited)	USOCR	2004/05/11 09:42
3	2098	(semiconductor) and (conductive or conductor or interconnect or interconnection or interconnecting) and dielectric and (ablate or erosion or ablation or erode or eroded or ablated) and (deposit or deposition or deposited) and laser and component	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/05/11 09:53
4	100	(semiconductor) and (conductive or conductor or interconnect or interconnection or interconnecting) and (dielectric near (ablate or erosion or ablation or erode or eroded or ablated)) and (deposit or deposition or deposited) and laser and component	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/05/11 09:52
5	5	(semiconductor) and (conductive or conductor or interconnect or interconnection or interconnecting) and ((dielectric and laser) near (ablate or erosion or ablation or erode or eroded or ablated)) and (laser near (deposit or deposition or deposited)) and component	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/05/11 09:44
6	5	(semiconductor) and (conductive or conductor or interconnect or interconnection or interconnecting) and (dielectric near (ablate or erosion or ablation or erode or eroded or ablated)) and (laser near (ablate or erosion or ablation or erode or eroded or ablated)) and (laser near (deposit or deposition or deposited)) and component	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/05/11 09:45
7	31	((semiconductor) and (conductive or conductor or interconnect or interconnection or interconnecting) and (dielectric near (ablate or erosion or ablation or erode or eroded or ablated)) and (deposit or deposition or deposited) and laser and component) and ((component or semiconductor) near (bonding or bond or interconnection or connect))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/05/11 09:54